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A new acoustic resonator concept based on acoustic waveguides using Silicon/Periodically Poled Transducer/Silicon structures for RF applications

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Abstract: We propose a new acoustic resonator concept based on a periodically poled transducer (PPT) in a piezoelectric substrate (LiNbO_3 or LiTaO_3), embedded between two guiding substrates in order to create an acoustic waveguide. A resonator operating at 131MHz have been successfully fabricated and used in order to stabilize an oscillator. However the fabricated resonator presents a significant thermal sensitivity. The following experiments have consisted in studying a Si/thinned PPT layer/Si in order to reduce the thermal sensitivity.

I. INTRODUCTION

Surface Acoustic Waves resonators are usually used for the frequency stabilization of electrical oscillators in the range of 50 MHz to 2 GHz. We have developed an isolated wave guide allowing for the propagation of acoustic waves within a PPT plate (LiNbO_3 or LiTaO_3) in between two silicon guiding substrates, yielding advanced packaging opportunities. In the first part, we present the simulation, the fabrication and the characterization of a PPT-based resonator operating at 131 MHz with a Silicon(380 μm)/ LiNbO_3 PPT(500 μm)/Silicon(380 μm) structure. We present the resonator oscillation characteristics, more particularly the phase noise and the frequency stability. In a second part, we exhibit the advantages of thinning down the piezoelectric transducer in showing the dispersion properties analysis. We describe the fabrication process and the characterization of resonators based on thinned PPLN or PPLT layers. The phase noise of an oscillator using a Si/PPLN/Si resonator, exhibiting a 50 μm period and a 500 μm thick piezoelectric layer, has pointed out the concept feasibility and answers to scope statement. In fact, these resonators, with low insertion losses and a phase noise at 100 kHz of the carrier wave controlled, less than 160dBc/Hz, are well-suited for radar applications. Moreover, for each PPT period, the dispersion properties analysis has shown an optimum thickness of the piezoelectric plate, corresponding to the maximum electromechanical coupling coefficient. Si/PPT/Si test vehicles, exhibiting a 50 μm period and a thick piezoelectric layer around 30 μm , have pointed out the existence of an isolated mode operating at frequencies near 110MHz for a LiNbO_3 PPT and near 90MHz with LiTaO_3 PPT with low thermal sensitivities.

II. BASIC PRINCIPLES OF THE PPT-BASED RESONATOR

We propose a new guiding concept using interface ultrasonic waves. We suggest a compact structure based on poled ferroelectric layer bonded between two guiding substrates (fig.1). An acoustic wave is excited by a periodically poled transducer, and the waves then are trapped within a buried guiding structure. LiNbO_3 or LiTaO_3 as piezoelectric and ferroelectric materials are exploited to fabricate the PPT's [1] and silicon substrates are used to guide the acoustic wave and allow for a low cost packaging [2]. These components have to operate at high frequencies (RF until X band domain) and need spectral purity, short-term stability, low phase noise around the carrier wave and thermal insensitivity notably for radar applications. PPTs have been investigated recently as an alternative to standard periodic inter-digital

transducers (IDTs) for the excitation and detection of guided acoustic waves [2] and consist of a periodic alternation of oppositely poled ferroelectric domains included between two electrodes. The main advantages of PPTs compared to standard IDTs are the robustness of the excitation versus defects or surface contamination, the opportunity to excite fundamental waves exhibiting an operating frequency twice higher and the possibility to excite several waves at the same time.

Fig. 1. Principle of the PPT isolated wave transducer

III. Si/thick PPT/Si- BASED WAVEGUIDE, RESONATOR AND OSCILLATOR

The fabrication of acoustic waveguides based on PPTs consists in bonding a silicon wafer on each side of the periodically poled wafer. LiNbO₃ or LiTaO₃ as piezoelectric and ferroelectric materials are good candidates for the fabrication of the PPTs. In fact, these materials have a spontaneous polarization which can be inverted by applying high voltage thanks to our home-made poling technique [3]. The voltage needed to invert the domains is around 11kV for a 500μm-thick wafer. The different steps of fabrication are detailed in fig. 2 and reported in reference [4].

Fig.2. Flow-chart of fabrication

Fig.3. SEM view of a Si/PPT/ Si transducer

On figure 3, we can see a SEM observation of poled domains after HF wet etching for a 50μm period of this Si/500μm PPT/Si structure. The different domains confined between the 2 doped silicon layers are clearly observed. Operational test vehicles with a 50μm period have been achieved using doped silicon wafers in order to ease the electrical contact and tested by means of a spectrum analyzer yielding Si/PPT/Si devices responses.

Theoretical and measured electrical admittances agree well and allow for identifying a main contribution corresponding to a guided longitudinal mode at 131 MHz (fig.4). The corresponding phase velocity is very close to the one of the PPT alone (i.e 6500 m.s^{-1}) [3]. This resonator operating near 131MHz exhibits a quality factor of 13000 and an electromechanical coupling ks^2 equal to 0.25% (twice higher than a SAW quartz resonator). The corresponding phase rotation (320°) and the dynamic of its electrical reflection coefficient S_{11} equal to -8dB reveal compatible with oscillator applications (fig.5).

A specific printed circuit has been implemented for the phase noise tests with our Si/500µm PPT/Si resonator and the Colpitts oscillator (fig.6). The phase noise of the oscillator at 100kHz from the carrier shows a value less than -160dBc/Hz (fig.7), which can be honestly compared with other acoustic wave oscillators at such frequency, accounting for the fact that the device was excited with a quite low signal level (-6dBm). Therefore, increasing the excitation should allow for a significant reduction of the noise floor and then advantageously compete with standard solutions.

We have also studied the stability of this 131MHz oscillator, and we have obtained a frequency stability equal to 10^{-9} at less than 1s (fig.8). This experiment has been made at room temperature without any thermal compensation.

Fig.8. Frequency stability curve of 131 MHz oscillator

Fig.9. Frequency drift versus temperature for the longitudinal mode

The frequency drift of this longitudinal mode at 131MHz versus the temperature is reported in fig.9. We have found frequency variations of -78ppm/K for the longitudinal mode for a thick LiNbO_3 layer bonded between two Silicon layers. This value is sensibly the same than the one of isolated LiNbO_3 devices. We can conclude that we obtain a significant thermal sensitivity for Si/thick LiNbO_3 layer/Si and this value depends essentially of the material used for the PPT layer and cannot be reduced by the two guiding substrates. The further experiments consists in studying a Si/thinned PPT layer/Si in order to obtain a monomode acoustic wave device with an isolated mode with a low thermal sensitivity.

IV. Si/thinned PPT/Si- BASED WAVEGUIDES

The study of the dispersion properties enables to define a specific configuration using a thinned PPT layer [4]. Interesting guidance properties have been obtained for a ratio between the thickness of the layer and the period of inverted domains lower than 1 and as a result the maximum of the electromechanical coupling is obtained for a 25-35 μm thick $\text{LiNbO}_3/\text{LiTaO}_3$ layer for a 50 μm period. The global flow-chart to fabricate Si/thinned PPT layer/Si acoustic waveguides is approximately the same than the process used for Si/thick PPT/Si (fig.2). The supplementary step consists in lapping and polishing the PPT layer in order to obtain a thinned PPT layer of about 25-35 μm , thanks to our lapping machine (fig.10). Finally this material stack is bonded on a second doped silicon wafer in order to define the aimed compact structure Si/PPT/Si. On figure 11, we can see a SEM observation obtained for a 25 μm thick LiNbO_3 layer confined between the two silicon substrates for a 50 μm period.

Fig.10. Photograph of the equipment used for lapping/polishing operations

Fig.11. SEM view of a Si/thinned PPT/Si transducer

Operational test vehicles have been achieved using LiNbO_3 and LiTaO_3 wafers as poled ferroelectric layer. Experimental results of the Si/thinned PPT layer/Si devices with a $50\mu\text{m}$ period are reported in fig.12. For the two materials, only one contribution is obtained: at 110MHz for a $25\mu\text{m}$ thick LiNbO_3 layer and at 88MHz for a $35\mu\text{m}$ thick LiTaO_3 layer. Unfortunately, these monomode acoustic devices, due to a non homogenous thickness of the PPT layer along the several millimeter long ferroelectric gratings, don't exhibit properties compatible with oscillator applications.

Fig.12. Theory/experiment assessment for a Si/thinned PPT/Si device with $50\mu\text{m}$ of poling period built on a Z-cut LiNbO_3 plate ($25\mu\text{m}$) (a) and a Z-cut LiTaO_3 plate ($35\mu\text{m}$) (b)

We have also studied the frequency drift of the isolated mode versus the temperature for a $50\mu\text{m}$ period structure (fig.13). We have found frequency variations of -33ppm/K for the isolated mode for a $25\mu\text{m}$ thick LiNbO_3 layer and of -31ppm/K for a $35\mu\text{m}$ thick LiTaO_3 layer. So we can conclude that bonding onto two silicon wafers and lapping/polishing the LiNbO_3 layer have compensated this frequency drift versus temperature by a factor 2. Moreover the temperature coefficient of frequency (TCF) value of the compact structure is close to the TCF value of the silicon guiding substrate. So we can conclude that if we choose an appropriate insensitive material as guiding substrate, we can obtain an insensitive resonator versus temperature.

Fig.13. Frequency drift versus temperature for the isolated mode of a 50μm period device-theory/experiment assessment on a Z-cut LiNbO₃ plate (25μm) (a) and a Z-cut LiTaO₃ plate (35μm) (b)

V. CONCLUSION

We have proposed a new acoustic resonator concept based on a periodically poled transducer in a piezoelectric substrate (LiNbO₃ or LiTaO₃) embedded between two silicon guiding substrates in order to create an acoustic waveguide. A resonator operating at 131MHz have been successfully fabricated. This resonator presents the required properties to stabilize an oscillator at this frequency but however the developed resonator presents a significant thermal sensitivity (depending mainly on PPT substrate used). The following experiments have consisted in studying a Si/thinned PPT layer/Si: monomode acoustic wave devices with an isolated mode have been successfully fabricated with a low thermal sensitivity. A thermal insensitivity is possible with an appropriate choice of guiding substrate. However these monomode devices don't exhibit properties compatible with oscillator requirements due mainly to technological limits to be solved. Future works consist in improving the lapping process in order to obtain a homogeneous thickness for the compact structure, studying the possibility to reduce the noise floor of the oscillator with increasing the input power of the resonator at 131MHz and trying to invert micrometric periods in order to achieve a 2GHz frequency resonator.

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REFERENCES

- [1] E. Courjon et al, "Pure longitudinal plate mode excited by poled domains transducers on LiNbO₃", Proc. of the IEEE IFCS, 2007
- [2] E. Courjon et al, "Fabrication of periodically poled domains transducers on LiNbO₃", Proc. of the IEEE IFCS, 2006
- [3] E. Courjon et al, "Lamb wave transducers built on periodically poled Z-cut LiNbO₃ wafers", Journal of Applied Physics, 102, 114107, 2007
- [4] E. Courjon et al, "An acoustic wave guide based on doubly-bonded silicon/PPT/silicon structures", Proc. of the joint IEEE IFCS-EFTF, 2009